

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Jeng H. Hwang et al.

Serial No.: 10/057,674

Filed: January 24, 2002

Title: MASKING METHODS AND ETCHING  
SEQUENCES FOR PATTERNING ELECTRODES  
OF HIGH DENSITY RAM CAPACITORS

§ Group Art Unit: 1756  
§  
§ Examiner: N. Barreca  
§  
§  
§ Attorney Docket No.:  
§ AM-2602.Y1  
§

Date: March 18, 2004

**PETITION FOR EXTENSION OF TIME**

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

1. This is a petition for a three-month extension of the time to file a response to the Office Action mailed October 3, 2003 in the subject patent application. The due date for the response was January 3, 2004, and the present three month extension of time will provide for a response through April 5, 2004.

**CERTIFICATE OF MAILING UNDER 37 CFR § 1.10**

I hereby certify that this paper and documents accompanying this paper are being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ER534275277US in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

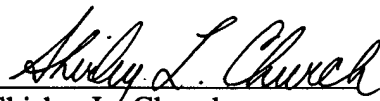
Date: March 18, 2004

By: Shirley L. Church  
Shirley L. Church, Reg. No. 31,858

2.	Extension:	<u>Length of Extension</u>	<u>Fee Under 37 CFR § 1.17</u>
		<u>    </u> One-Month	\$110.00
		<u>    </u> Two-Month	\$420.00
		<u>  X  </u> Three-Month	\$950.00
		<u>    </u> Four-Month	\$1,480.00

3. The accompanying transmittal letter shows this fee of \$ 950.00 for the three-month extension of time. The transmittal letter is submitted in duplicate for accounting purposes.

Respectfully Submitted,

  
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